

## **Inventor Information**

Inventor One Given Name::	Yoshiro
Family Name::	SHIOKAWA
City of Residence::	Hachioji-shi
Country of Residence::	JAPAN
Citizenship Country::	JAPAN
Inventor Two Given Name::	Megumi
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Citizenship Country::	JAPAN
Inventor Three Given Name::	Tohru
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Country of Residence::	JAPAN
Citizenship Country::	JAPAN
Inventor Four Given Name::	Toshihiro
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City of Residence::	Hamura-shi
Country of Residence::	JAPAN
Citizenship Country::	JAPAN

## **Correspondence Information**

Correspondence Customer Number::	25944
Name Line One::	Oliff & Berridge PLC
Address Line One::	P.O. Box 19928
City::	Alexandria
State or Province::	VA
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## **Application Information**

Title Line One::	METHOD AND APPARATUS FOR ION
Title Line Two::	ATTACHMENT MASS SPECTROMETRY
Total Drawing Sheets::	10
Docket Number::	109675

## **Prior Foreign Applications**

Foreign Application One::	2000-169644
Filing Date::	June 6, 2000
Country::	JAPAN
Priority Claimed::	YES

## **Assignee Information**

Name of assignee::	ANELVA CORPORATION
Assignee Address Line One::	8-1, Yotsuya 5-chome,
City::	Fuchu-shi
State or Province::	Tokyo
Country::	JAPAN

09870736-060101